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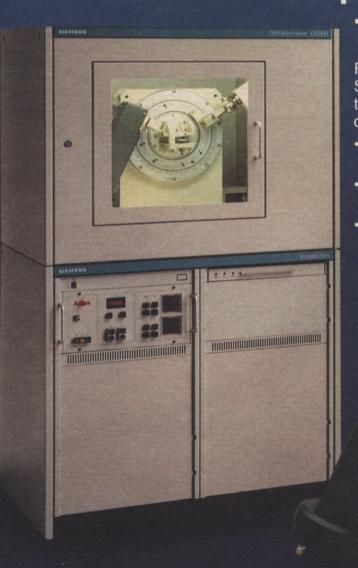


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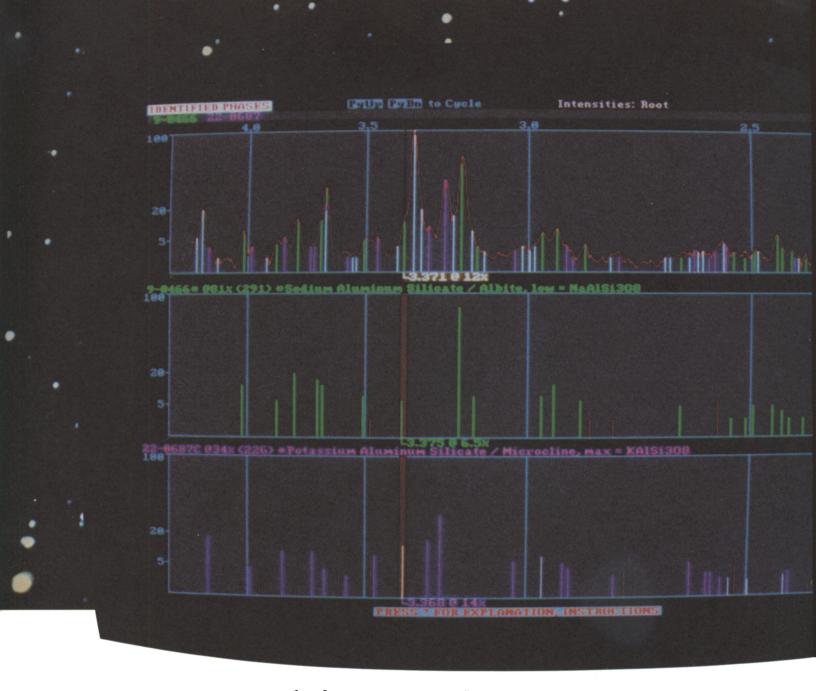
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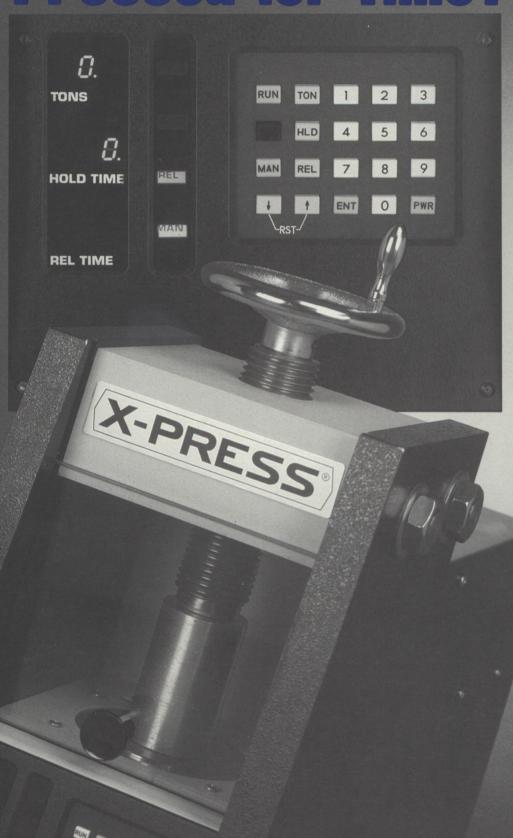
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Manuscript submissions. The Editors will consider all manuscripts received, but assume no responsibility regarding them. Materials will be returned only when accompanied by appropriate postage.

Subscriptions. The annual subscription rate in the United States and Canada is \$45.00; Library; \$85.00; other than U.S.A., Canada and the Far East, the annual al subscription is \$65.00. Subscriptions to the Far East, including Japan, China, Taiwan, Malaysia, the Philippines, Indonesia and Korea should be made via Sanyo Information System Corp., Taiyo Bldg. 7-7, Tomizawa-cho Nihonbashi, Chuo-ku, Tokyo 103, Japan. Airmail delivery available for subscribers outside U.S./Canada for an additional cost of \$35.00 per volume (4 issues).

Payment may be made in U.S. dollars by company check, MasterCard, Visa or international money order. Please address communications to the publisher's

Advertising. For advertising rates and schedules contact the Publisher's Office JCPDS-International Centre for Diffraction Data, 1601 Park Lane, Swarthmore, PA 19082, Telephone (215) 328-9405.

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Postal Information. Powder Diffraction (ISSN 0885-7156) is published quarterly for \$45.00 a year (U.S. and Canada) by JCPDS-International Centre for Diffraction Data, 1601 Park Lane, Swarthmore, Pa. 19081. Julian Messick, Jr., General Manager. © 1990 JCPDS-International Centre for Diffraction Data. Postmaster: Send address changes to JCPDS-International Centre for Diffraction Data, 1601 Park Lane, Swarthmore, Pennsylvania 19081.

International CODEN Service (Intercode): PODIE2 ISSN 0885-7156 Telex 847170 FAX 215 328 2503

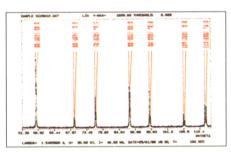


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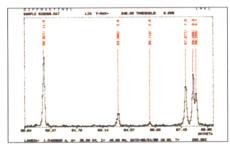


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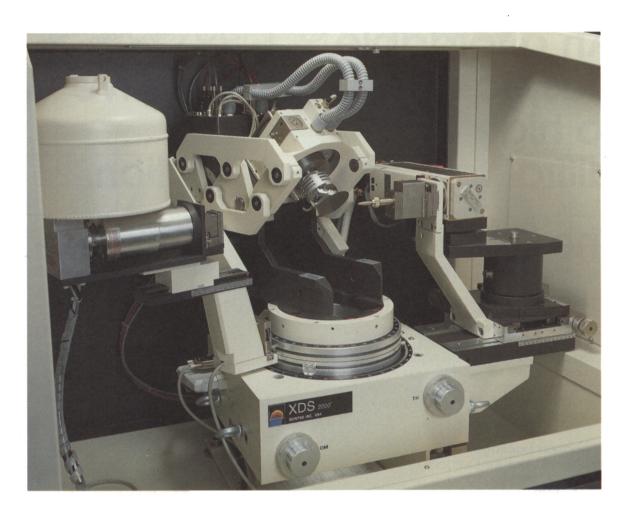
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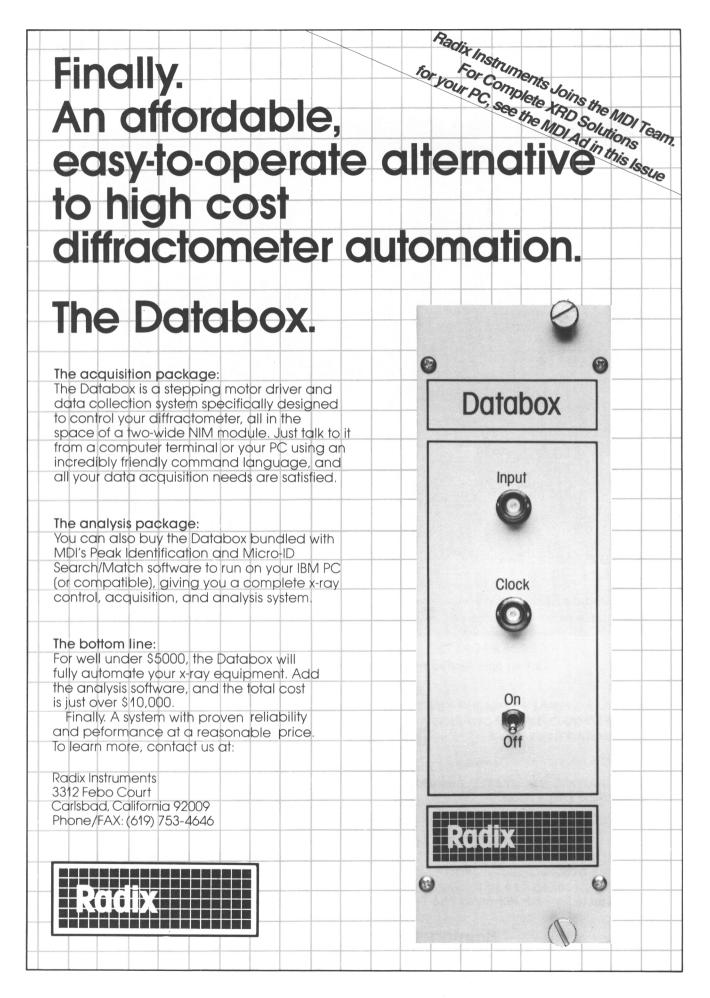
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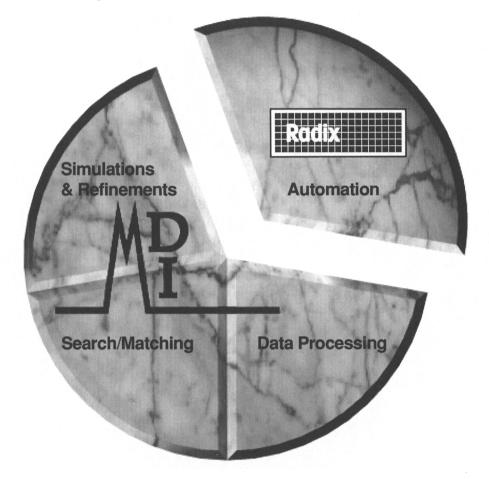
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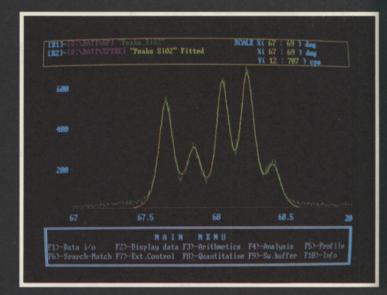
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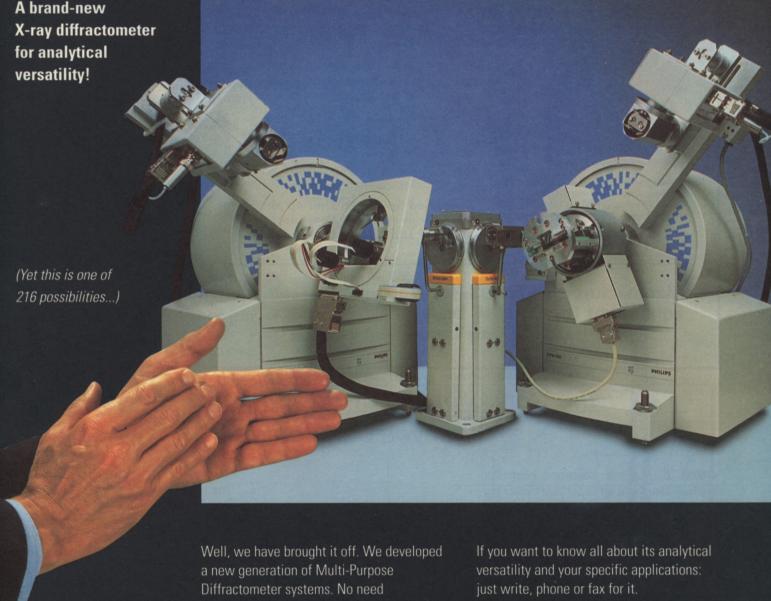
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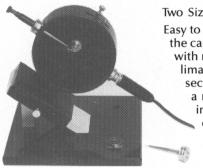
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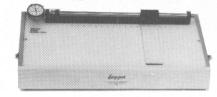
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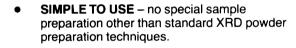
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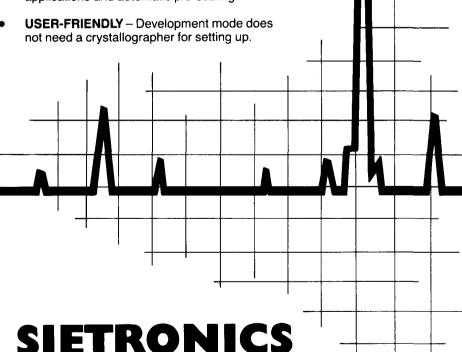
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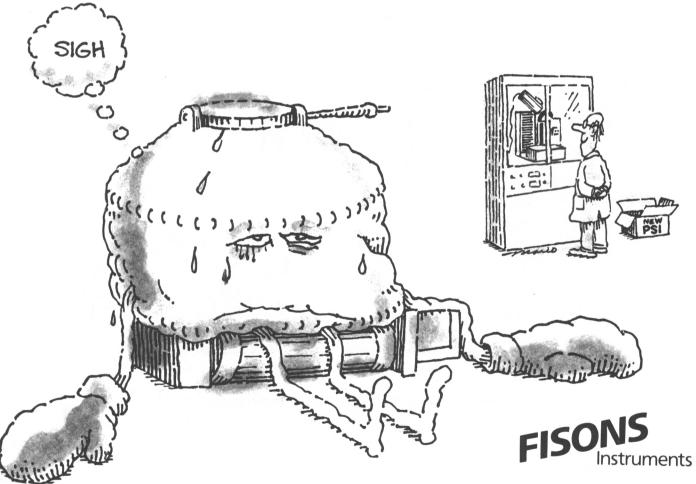
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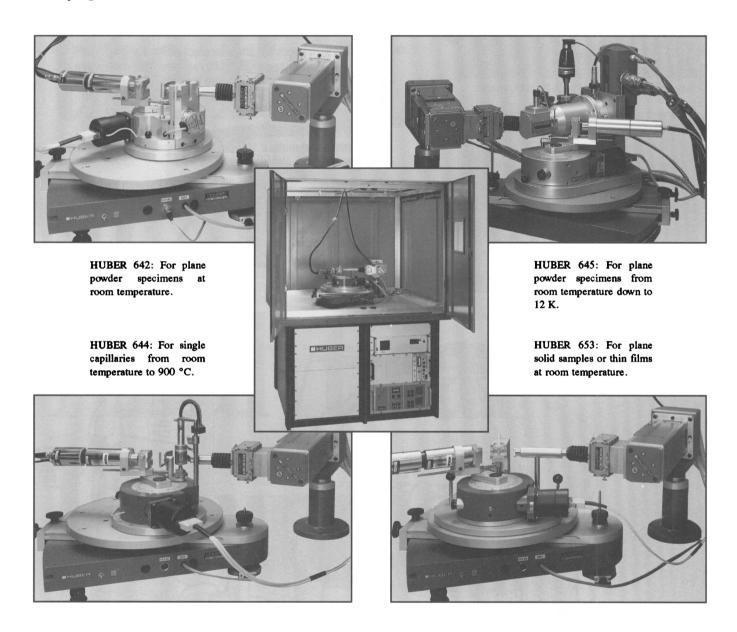
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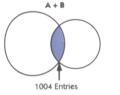


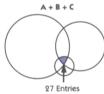


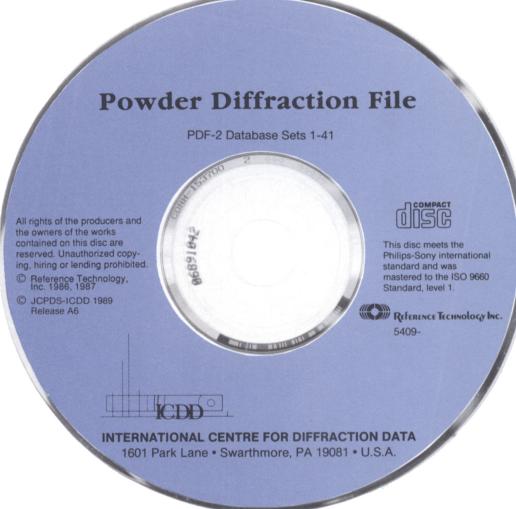


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PD17

New Scholarships in Crystallography

In spite of the importance of crystallography in chemistry, physics, geology, materials science and biology, there are very few scholarships for which the central theme of the support is crystallographic research. Most materials-oriented crystallographic research is part of larger projects on understanding or synthesizing compounds or materials for specific properties or applications where the student needs to determine the structure-property relationships. The only scholarship specifically emphasizing crystallography known to this author is the Kraus Award given by the Mineralogical Society of America. If there are other such scholarships, I request readers to provide me with the general information, and I will pass the information on to our general readership.

Now the International Centre for Diffraction Data has created a new scholarship program to support research in crystal-lography. The initial awards in this program will be for 1992, and the details of this program are presented in the announcement accompanying this editorial. This program is a welcome addition to the support of our scientists in training. I encourage qualified students to apply for these scholarships. I also encourage any company or individual who would like to contribute to a worthwhile cause to contact the General Manager of the ICDD for further information about this program.

Deane K. Smith Editor-in-Chief

Crystallography Scholarship Fund of JCPDS-ICDD

The science of crystallography has played a key role in the development of X-ray diffraction, electron diffraction and neutron diffraction for the elucidation of the atomic structure of matter. Crystallography is an interdisciplinary branch of science taught in departments of physics, chemistry, geology, molecular biology, metallurgy, and materials science. To encourage promising graduate students to pursue crystallographically-oriented research, the International Centre has embarked on establishing a Crystallography Scholarship Fund. While the Ewald Prize is awarded every three years to an internationally recognized crystallographer, little effort has been made by science departments to cultivate aspiring crystallographers. Convinced of the beneficial, scientific impact of the proposed scholarships for crystallographicallyoriented research, the ICDD Chairman has initiated the solicitation of funds from private and industrial sectors to reach the goal of \$250,000. Approximately one-third of this goal has been reached and the Board of Directors of ICDD has decided to initiate this program by offering two scholarships for the calendar year 1992. The following qualifications and restrictions are to be met:

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- e. The awarding of the scholarships is to be administered by a committee consisting of the ICDD Chairman, Chairman of the ICDD Technical Committee, and the Chairman of the ICDD Education Subcommittee. One or more accredited professors (with no conflicts of interest) may be invited to assist in the selection of successful candidates.

Applications should be mailed, prior to October 31, 1991, to:

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Ludo K. Frevel, Chairman ICDD